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V. Vannell

Applicants: Jammy et al. Examiner: A. Ghyka
Serial No: 09/594,638 Group Art Unit: 2812
Filed: June 15, 2000 Docket: 99P7722 US 01 (8055-98)

For: **METHOD FOR FORMING CRYSTALLINE SILICON NITRIDE**

Assistant Commissioner for Patents
Washington, D.C. 20231

AMENDMENT UNDER 37 C.F.R. §1.111

Sir:

This is a response to the Office Action mailed on May 9, 2001. Please consider the following amendments and remarks.

CERTIFICATE OF MAILING 37 C.F.R. §1.8(a)

I hereby certify that this correspondence (and any document referred to as being attached or enclosed) is being deposited with the United States Postal Service as first class mail, postage paid in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231 on **August 9, 2001**.

Dated: 8/9/01


James J. Brutto, Esq.